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IN THE SPECIFICATION:

Beginning on page 1, please amend the following:

A High Repetition Rate Laser Produced Plasma EUV Light Source

**Robert P. Akins
Richard L. Sandstrom
William N. Partlo
Igor V. Fomenkov
Thomas D. Steiger
J. Martin Algots
Norbert R. Bowering
Robert N. Jacques
Frederick A. Palenschat
Jun Song**